

Low-Temperature Chemical Sintered TiO₂ Photoanodes Based on a Binary Liquid Mixture for Flexible Dye-Sensitized Solar Cells

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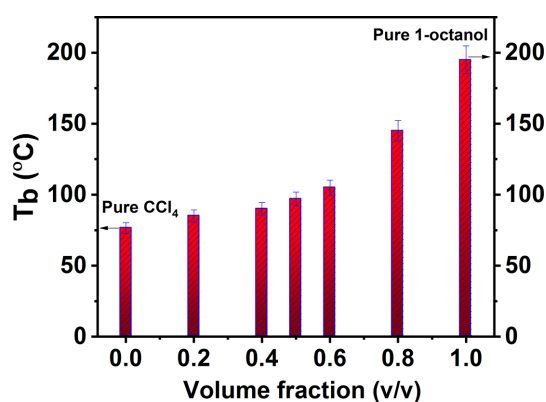


Fig. S1. Variations of the boiling points of CCl₄ and 1-octanol mixture against their volume fractions.



Fig. S2. Photographic images of the 150°C sintered TiO₂ films prepared using (a) P_{BL} and (b) P_O before and after UV-O₃ treatment.

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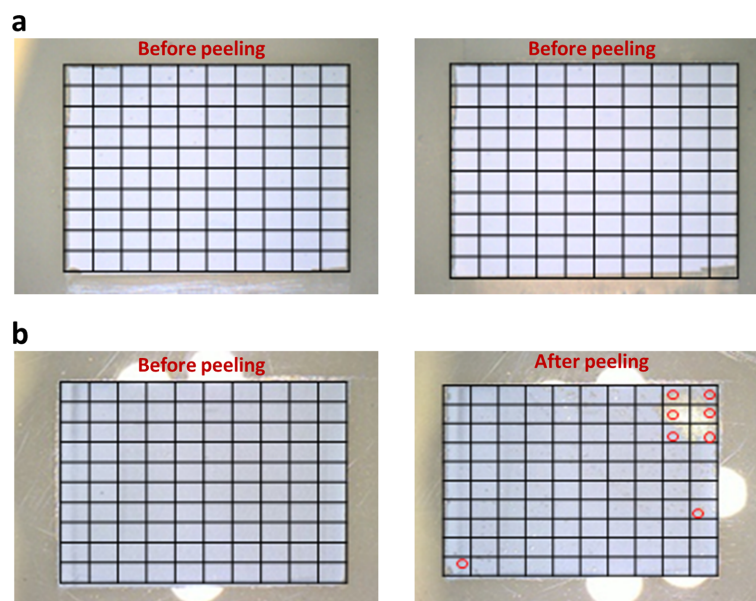


Fig. S3. Photographic images of TiO₂ films prepared using (a) P_{BL} and (b) P_O pastes before and after scotch tape scratch test. The TiO₂ films were prepared by doctor method onto glass/FTO substrates and sintered at 150°C followed with the subsequent UV-O₃ treatment.

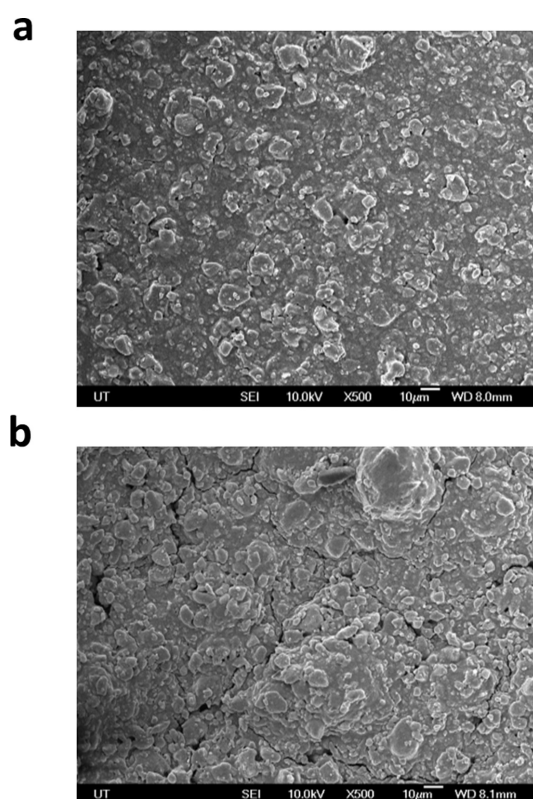


Fig. S4. FE-SEM images of room temperature dried TiO₂ films prepared using (a) P_{BL} and (b) P_O pastes.

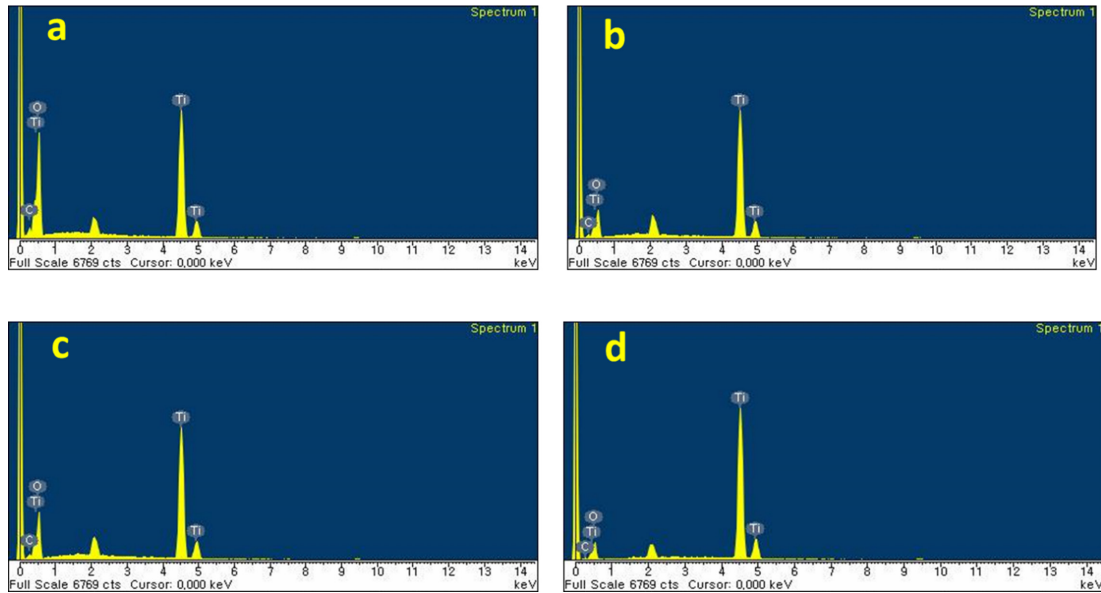


Fig. S5. EDS spectra of P_{BL} TiO_2 film at different treatment conditions: (a) 25°C, (b) 150°C, (c) 150°C+ UV- O_3 , and (d) 500°C.

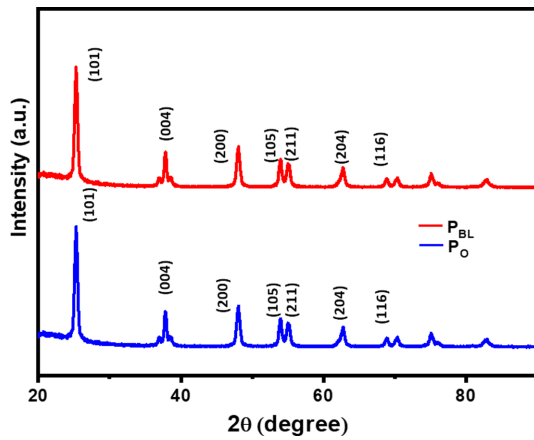


Fig. S6. XRD pattern of P_{BL} and P_O TiO_2 films sintered at 150°C followed with the subsequent UV- O_3 treatment.

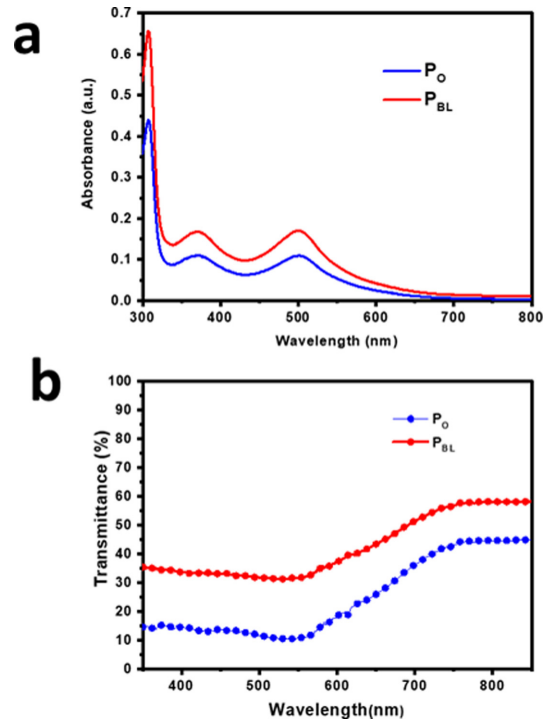


Fig. S7. (a) UV-vis absorption spectra of N719 dye detached from the dye-anchored TiO_2 film of P_{BL} and P_O in 0.1 M $NaOH_{(aq)}$. (b) Transmittance spectra of P_{BL} and P_O TiO_2 films sintered at 150°C with the subsequent UV- O_3 treatment.

Table S1. Comparison PCE of previously reported low-temperature TiO₂ pastes based DSSCs.

| Chemical sintering agents | Photoanode Substrates | CE substrates | Type of full device | Sintering Temp (°C) | PCE (%) | Ref. |
|---|-----------------------|---------------|---------------------|---------------------|---------|-----------|
| Mixture of water, t-butanol | ITO/PEN | FTO/glass | Rigid | 150 | 5.8 | S1 |
| Nanoglue | ITO/PEN | FTO/glass | Rigid | 150 | 5.43 | S2 |
| HCl | ITO/PEN | ITO/PEN | Flexible | 150 | 5.0 | S3 |
| Zn NPs | FTO/glass | FTO/glass | Rigid | 200 | 4.92 | S4 |
| H ₂ TiF ₆ | ITO/PET | FTO/glass | Rigid | 120 | 4.2 | S5 |
| NH ₄ OH | ITO/PET | ITO/glass | Rigid | 150 | 5.44 | S6 |
| CH ₃ COOH and NH ₄ OH | FTO/glass | FTO/glass | Rigid | 150 | 2.55 | S7 |
| Binary-Liquid | Glass/FTO | Glass/FTO | Rigid | 150 | 6.0 | This work |
| | ITO/PEN | ITO/PEN | Flexible | 150 | 3.5 | |

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